



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.:

10/706,862

Confirmation No.: 6724

Applicant(s):

Ogihara et al. 11/12/2003

Filed: Title:

COMPOSITION FOR FORMING POROUS FILM, POROUS FILM AND

METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR FILM, AND

SEMICONDUCTOR DEVICE

Docket No.:

035576/271443

Customer No.: 00826

June 25, 2004

Mail Stop Missing Parts Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT 37 CFR § 1.115

Sir:

Please enter this Preliminary Amendment before calculating the claim fee and amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 4 of this paper.